

TSMC-00-166



March 18, 2002

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To: Commissioner of Patents and Trademarks
Washington, D.C. 20231

Fr: George O. Saile, Reg. No. 19,572
20 McIntosh Drive
Poughkeepsie, N.Y. 12603

RECEIVED
OCT 23 2002
OFFICE OF PETITIONS

Subject: | Serial No. 09/679,514 10/06/00 |
| Hung-Jen Hsu |

"A METHOD TO IMPROVE PASSIVATION
OPENINGS BY REFLOW OF PHOTORESIST
TO ELIMINATE TAPE RESIDUE"

Grp. Art Unit: 2823 B. KEBEDE

RESPONSE PATENT OFFICE ACTION

Dear Sir:

In response to the Office Action dated December 20, 2001,
please amend the above-identified application for patent as
follows:

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being
deposited with the United States Postal Service as first
class mail in an envelope addressed to: Commissioner of
Patent and Trademarks, Washington, D.C. 20231, on March 20,
2002.

Stephen B. Ackerman Reg. No. 37,761

Signature [Signature]
Date 3/20/02